

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kenichi Ishibashi et al.
Serial No.: 10/543,050
Confirmation No.: 2592
Filed: July 21, 2005
For: PHOTOELECTRIC CONVERSION ELEMENT AND PROCESS
FOR FABRICATING THE SAME, ELECTRONIC APPARATUS
AND PROCESS FOR FABRICATING THE SAME, AND
SEMICONDUCTOR LAYER AND PROCESS FOR FORMING THE
SAME
Examiner: C. L. Novacek
Art Unit: 2822

Certificate of Electronic Filing Under 37 CFR 1.8

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted via the Office electronic filing system in accordance with § 1.6(a)(4).

Dated: May 27, 2009

Signature:  (Sheila F. Gravina)

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Madam:

INTRODUCTORY COMMENTS

In response to the Office Action mailed February 27, 2009, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.